

PTO-1449		Application No. 09/862,814		Applicant(s) John C. Seibel et al.		#7 SP	
<b>Information Disclosure Citation in an Application</b>		Docket Number 067082.0114		Group Art Unit 2177		Filing Date 01-06-04	
						5/21/01	
<div style="float: left; border: 1px solid black; border-radius: 50%; padding: 5px; text-align: center;">             DEC 19 2003              U.S. PATENT &amp; TRADEMARK OFFICE           </div> <div style="float: right; text-align: right;">             RECEIVED              JAN 02 2004              Technology Center 2100           </div> <div style="clear: both;"></div>							
U.S. PATENT DOCUMENTS							
		DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
		4914586	4/3/90	Swinehart et al.	364	200	11/6/87
W	B	6034970	3/7/00	Levac et al.	370	466	7/2/97
W	C	6199081	3/6/01	Meyerzon et al.	707	513	6/30/98
W	D	6493703	12/10/02	Knight et al.	707	3	5/11/99
W	E	6609124	8/19/03	Chow et al.	707	5	8/13/01
W	F	6611839	8/26/03	Nwabueze	707	101	3/15/01
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FOREIGN PATENT DOCUMENTS							
		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
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NON-PATENT DOCUMENTS							
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EXAMINER <i>H. S. Lu</i>					DATE CONSIDERED <i>2/18/2004</i>		
EXAMINER: Initial if citation considered whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.							